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10/813,959

Applicant(s)

Hee-Jung PARK, et al.

Filing Date

3-30-2004

Group Art Unit

NYA

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

Tue

DATE CONSIDERED

10-20-2005

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.